

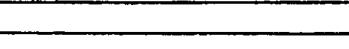
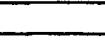
Substitute for form 1449A/PTO	ATTORNEY'S DKT NO. 033033-002	APPLICATION NO. 09/889,956
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>	APPLICANT Hans-Joachim QUENZER et al.	
	FILING DATE July 25, 2001	GROUP Unassigned

# U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

Examiner Initials	Foreign Patent Document		Country	Date of Publication (MM-DD-YYYY)	Translation	
	Number	Kind Code (if known)			Yes	No
CL	0 567 896	A1	EUROPE	11/03/1993		
✓	97/19027	A1	INTERNATIONAL	5/29/1997		
✓	0 690 028	A1	EUROPE	1/03/1996		
✓	0 493 202	A1	EUROPE	7/01/1992		
CL	1 596 490		GERMANY	5/19/1971		

NON-PATENT LITERATURE DOCUMENTS

EXAMINER LITERATURE DOCUMENT		
Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
CL	Dong QUIN et al., "Microfabrication, Microstructures and Microsystems", <i>Topics in Current Chemistry</i> , Vol. 194, <i>Microsystem Technology in Chemistry and Life Sciences</i> , Springer Verlag, Berlin Heidelberg 1998, pages 1-20.	
	Jean SCHULZE et al., "Compact Self-Aligning Assemblies with Refractive Microlens Arrays Made by Contactless Embossing", <i>SPIE</i> , Vol. 3289, pages 22-32.	
CL	Thierry CORMAN et al., "Low-Pressure-Encapsulated Resonant Structures with Integrated Electrodes for Electrostatic Excitation and Capacitive Detection", <i>Sensors and Actuators A</i> 66, 1998, pages 160-168.	
Examiner Signature		Date  13.10.98

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. SEND TO: Assistant Commissioner for Patents, Washington, D.C. 20231.